

# Search Notes



Application/Control No.

09/774,667

Examiner

Gevell Selby

Applicant(s)/Patent under Reexamination

MIIDA, TAKASHI

Art Unit

2615

## SEARCHED

Class	Subclass	Date	Examiner
348	294 298 300	6/3/05	GS
	301		
	308		
250	208.1		
257	292		

## INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner
348	294	6/3/05	GS
	298		
	300		
	301		
	308		

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
Updated Search	6/3/05	GS
Inventorship search	6/3/05	GS